

Title (en)
SYSTEM MANAGING GAS FLOW BETWEEN CHAMBERS OF AN EXTREME ULTRAVIOLET (EUV) PHOTOLITHOGRAPHY APPARATUS

Title (de)
SYSTEM ZUR REGELUNG EINES GASSTROMS ZWISCHEN KAMMERN EINES EUV-PHOTOLITHOGRAFIEGERÄTS

Title (fr)
SYSTÈME DE RÉGULATION D'UN FLUX DE GAZ ENTRE DES CHAMBRES D'UN APPAREIL POUR LA PHOTOLITHOGRAPHIE PAR ULTRAVIOLET EXTRÊME (EUV)

Publication
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Application
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Abstract (en)
[origin: WO2009032055A1] A gas flow management system may comprise a first and second enclosing walls at least partially surrounding first and second respective spaces; a system generating plasma in the first space, the plasma emitting extreme ultraviolet light; an elongated body restricting flow from the first space to the second space, the body at least partially surrounding a passageway and having a first open end allowing EUV light to enter the passageway from the first space and a second open end allowing EUV light to exit the passageway into the second space, the body shaped to establish a location having a reduced cross-sectional area relative to the first and second ends; and a flow of gas exiting an aperture, the aperture positioned to introduce gas into the passageway at a position between the first end of the body and the location having a reduced cross-sectional area.

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